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## Customer No. 28289

## IAPS Rec'd PCT/PTO 10 FEB 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 7943

Application No.

Not Yet Assigned

**Applicants** 

Satoru WAKAMATSU et al.

Filed

Concurrently Herewith

Title

TUBULAR REACTION VESSEL AND PROCESS

FOR PRODUCING SILICON THEREWITH

International Application No.:

PCT/JP2004/011542

International Filing Date

11 August 2004

Priority Date(s) Claimed

13 August 2003

MAIL STOP PCT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 5 of this paper.